4	42	("3214315"   "3396401"   "3419321"   "3874240"   "3945318"   "4159414"   "4309224"   "4339285"   "4372989"   "4496607"	USPAT	2004/09/29 11:09
		"4159414"   "4309224"   "4339285"   "4372989"   "4496607"	1	
		"4539251"   "4565712"   "4620264"   "4624934"   "4663826"		
		"4761339"   "4791239"   "4840853"   "4847138"   "4860442"		
		"4880770"   "4912087"   "4924033"   "4950558"   "4988564"		
		"5015618"   "5055967"   "5145741"   "5180440"   "5391841"		
1		"5459098"   "5493096"   "5629532"   "5695828"   "5733609"		
		"5837607"   "5847418"   "5889234"   "6025609"   "6054375"		
		"6255671"   "6271576").PN.		
5	0	6670693.URPN.	USPAT	2004/09/29 12:38
9	2	6271576.URPN.	USPAT	2004/09/29 12:48
13	2	("3419321"   "5493096").PN.	USPAT	2004/09/29 12:50
14	4	5837607.URPN.	USPAT	2004/09/29 12:51
15	4	6025609.URPN.	USPAT	2004/09/29 12:52
16	3	("5629532"   "5837607"   "5847418").PN.	USPAT	2004/09/29 12:54
19	3	6054375.URPN.	USPAT	2004/09/29 12:57
22	267	((438/237).CCLS. (438/328).CCLS. (438/335).CCLS.	USPAT;	2004/09/29 14:17
	207	(438/378).CCLS. (438/380).CCLS. (438/535).CCLS.	US-PGPUB	2001/05/25 11.17
1		(438/667).CCLS.) and laser		
24	498	laser near2 synthesi\$6	EPO; JPO;	2004/09/29 14:05
47	790	laser flear 2 syriches spo	DERWENT;	200 1/03/23 11.03
1			IBM_TDB	
29	1399	438/237.ccls. 438/328.ccls. 438/335.ccls. 438/378.ccls.	USPAT;	2004/09/29 14:17
29	1399	438/380.ccls. 438/535.ccls. 438/667.ccls. 438/681.ccls.	US-PGPUB	2007/03/23 14.17
21	4	(438/237.ccls. 438/328.ccls. 438/335.ccls. 438/378.ccls.	USPAT;	2004/09/29 14:18
31	7	438/380.ccls. 438/535.ccls. 438/667.ccls. 438/681.ccls.) and	US-PGPUB	2004/03/23 14.16
			U3-PGPUB	
20	10	(laser near2 synthesi\$6)	EDO: 100:	2004/09/29 14:32
28	10	(laser near2 synthesi\$6) and ((compound near semiconductor)	EPO; JPO; DERWENT;	2004/03/23 14:32
		sic gan aln bn diamond (aluminum adj nitride) (boron adj		
		nitride) (gallium adj nitride) (silicon adj nitride) mocvd	IBM_TDB	
		"metallo-organic" "organo-metallic" organometallic		
	226	metal\$1organic bandgap (band adj gap))	LICDAT.	2004/00/20 14-26
27	226	(laser near2 synthesi\$6) and ((compound near semiconductor)	USPAT;	2004/09/29 14:26
		sic gan aln bn diamond (aluminum adj nitride) (boron adj	US-PGPUB	
		nitride) (gallium adj nitride) (silicon adj nitride) mocvd		
1		"metallo-organic" "organo-metallic" organometallic	1	
		metal\$1organic bandgap (band adj gap))	LICDAT	2004/00/20 14:10
32	943	laser same ((compound near semiconductor) sic gan aln bn	USPAT;	2004/09/29 14:40
		diamond (aluminum adj nitride) (boron adj nitride) (gallium adj	US-PGPUB	
1		nitride) (silicon adj nitride) bandgap (band adj gap)) same		
		(mocvd "metallo-organic" "organo-metallic" organometallic	1	
	_	metal\$1organic)		0004/00/05 := ==
35	231	laser and ((compound near semiconductor) sic gan aln bn	EPO; JPO;	2004/09/29 15:52
		diamond (aluminum adj nitride) (boron adj nitride) (gallium adj	DERWENT;	
1		nitride) (silicon adj nitride) bandgap (band adj gap)) and	IBM_TDB	
ł		(mocvd "metallo-organic" "organo-metallic" organometallic		
		metal\$1organic)		
33	5	(438/237.ccls. 438/328.ccls. 438/335.ccls. 438/378.ccls.	USPAT;	2004/09/29 14:41
Ì		438/380.ccls. 438/535.ccls. 438/667.ccls. 438/681.ccls.) and	US-PGPUB	
		(laser same ((compound near semiconductor) sic gan aln bn		
l		diamond (aluminum adj nitride) (boron adj nitride) (gallium adj		
ļ		nitride) (silicon adj nitride) bandgap (band adj gap)) same		
1		(mocvd "metallo-organic" "organo-metallic" organometallic		
		metal\$1organic))		
34	36	laser same ((compound near semiconductor) sic gan aln bn	USPAT;	2004/09/29 15:47
-		diamond (aluminum adj nitride) (boron adj nitride) (gallium adj	US-PGPUB	, , , =====
1		nitride) (silicon adj nitride)) same (bandgap (band adj gap))		
		same (mocvd "metallo-organic" "organo-metallic"		
į		organometallic metal\$1organic)		

14	laser and ((compound near semiconductor) sic gan aln bn	EPO; JPO;	2004/09/29 15:52
		IRW_LDR	
47		EPO: JPO:	2004/09/29 15:57
''		DERWENT;	
	nitride) (silicon adj nitride)) and (diode transistor fet bjt bipolar	IBM_TDB	
			2004/00/20 46 00
331		,	2004/09/29 16:08
	, , , , , , , , , , , , , , , , , , , ,	US-PGPUB	
185	· <del></del>	USPAT;	2004/09/29 16:59
	diamond (aluminum adj nitride) (boron adj nitride) (gallium adj	US-PGPUB	
	nitride) (silicon adj nitride)) same (diode transistor fet bjt		
		LICDAT	2004/00/20 10:21
3	66/0693.pn. 62/15/6.pn. 583/60/.pn.	,	2004/09/28 18:21
	47 331	diamond (aluminum adj nitride) (boron adj nitride) (gallium adj nitride) (silicon adj nitride)) and (bandgap (band adj gap)) and (mocvd "metallo-organic" "organo-metallic" organometallic metal\$10rganic)  47 laser and ((compound near semiconductor) sic gan aln bn diamond (aluminum adj nitride) (boron adj nitride) (gallium adj nitride) (silicon adj nitride)) and (diode transistor fet bjt bipolar m?sfet) and (mocvd "metallo-organic" "organo-metallic" organometallic metal\$10rganic)  331 (438/237.ccls. 438/328.ccls. 438/335.ccls. 438/378.ccls. 438/380.ccls. 438/535.ccls. 438/667.ccls. 438/681.ccls.) and laser  185 laser same ((compound near semiconductor) sic gan aln bn diamond (aluminum adj nitride) (boron adj nitride) (gallium adj nitride) (silicon adj nitride)) same (diode transistor fet bjt bipolar m?sfet) same (mocvd "metallo-organic" "organo-metallic" organometallic metal\$10rganic)	diamond (aluminum adj nitride) (boron adj nitride) (gallium adj nitride) (silicon adj nitride)) and (bandgap (band adj gap)) and (mocvd "metallo-organic" "organo-metallic" organometallic metal\$10rganic)  47 laser and ((compound near semiconductor) sic gan aln bn diamond (aluminum adj nitride) (boron adj nitride) (gallium adj nitride) (silicon adj nitride)) and (diode transistor fet bjt bipolar m?sfet) and (mocvd "metallo-organic" "organo-metallic" organometallic metal\$10rganic)  48 laser same ((compound near semiconductor) sic gan aln bn diamond (aluminum adj nitride) (boron adj nitride) (gallium adj nitride) (silicon adj nitride) (boron adj nitride) (gallium adj nitride) (silicon adj nitride)) same (diode transistor fet bjt bipolar m?sfet) same (mocvd "metallo-organic" "organo-metallic" organometallic metal\$10rganic)